

INFORMATION DISCLOSURE CITATION	ATTY. DOCKET NO.	SERIAL NO.
JUL 10 2003	925-160	09/667,527
(Use several sheets if necessary)	APPLICANT	
	MAKITA et al.	
	FILING DATE	GROUP
	September 22, 2000	2812

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

Ph	Lee et al, "Fabrication of High-Mobility p-Channel Poly-Si Thin Film Transistors by Self-Aligned Metal-Induced Lateral Crystallization", IEEE Electron Device Letters, vol. 17, no. 8, August 1996, pp. 407-409
Ph	Bhat et al, "The Effects of MIC/MILC Interface on the Performance of MILC-TFTs", Device Research Conf., 1998, pp. 110-111
Ph	Jin et al, "Performance of Thin-Film Transistors with Ultrathin Ni-MILC Polycrystalline Silicon Channel Layers", IEEE Election Device Letters, vol. 20, no. 4, April 1999, pp. 167-169

*Examiner

Date Considered

NOV-03

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)

